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MIO 0092 NA

10/765,314

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Application Number

Atomic Layer Deposition With Point Of Use Generated Reactive Gas Species The application data sheet is part of the provisional or nonprovisional application for which it is being submitted. The following form contains the bibliographic data arranged in a format specified by the United States Patent and Trademark Office as outlined in 37 CFR 1.76. This document may be completed electronically and submitted to the Office in electronic format using the Electronic Filing System (EFS) or the

Application Data Sheet 37 CFR 1.76

document may be printed and included in a paper filed application.

Title of Invention

Secrecy Order 37	CFR 5.2										
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Applicant Informa	tion:										
Applicant 1											
Applicant Authority (nventor OL	egal R	epresentati	ve und	ler 35	J.S.C. 1	17	Party of I	nterest un	der 35 U.S	S.C. 118
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All Inventors Must Be L generated within this form				Inform	nation	blocks	may b	e 	Add		
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Title of the Invention	Atomic Lay	er Dep	osition With	Point	Of Use	Genera	ted Read	tive Gas Sp	ecies		
Attorney Docket Numbe	r MIO 0092 N	IΑ			S	nall En	tity Sta	tus Claim	ed 🗌		
Application Type	Nonprovisio	nal									
Subject Matter	Utility										
Suggested Class (if any)				S	ub Clas	s (if an	y)			
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Application Data Sheet 37 CFR 1.76

Attorney Docket Number MIO 0092 NA
Application Number 10/765, 314

Title of Invention Atomic Layer Deposition With Point Of Use Generated Reactive Gas Species

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Request Early Publication (Fee required at time of Request 37 CFR 1.219)
Request Not to Publish. I hereby request that the attached application not be published under 35 U.S. C. 122(b) and certify that the invention disclosed in the attached application has not and will not be the subject of an application fled in another country, or under a multilateral international agreement, that requires publication at eighteen months after filing.

Representative Information:

Repres	entative	information	should be	provided	for all	practi	tioners having	a power o	of attorney	in the	applie	cation.	Providina
this info	ormation	in the Applica	ation Data S	Sheet doe	s not co	onstitut	e a power of atto	rney in the	application	n (see 3	7 CFF	1.32)	
Enter	either	Customer	Number	or cor	nplete	the	Representative	Name	section	below.	If	both	sections
are con	npleted t	he Customer	Number wi	II be used	for the	Repre	sentative Informa	ation during	g processir	ng.			
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Please Select One:	 Customer Number 	US Patent Practitioner	0	Limited Recognition (37 CFR 11.9)
Customer Number	23368			

Domestic Benefit/National Stage Information:

This section allows for the applicant to either claim benefit under 35 U.S.C. 119(e), 120, 121, or 365(c) or indicate National Stage entry from a PCT application. Providing this information in the application data sheet constitutes the specific reference required by 35 U.S.C. 119(e) or 120, and 37 CPFR 1.78(e)/20 or CPFR 1.78(e)(e)/4), and need not otherwise be made part of the specification.

Prior Application Status			Remove
Application Number	Continuity Type	Prior Application Number	Filing Date (YYYY-MM-DD)
		10091938	2002-03-05

Additional Domestic Benefit/National Stage Data may be generated within this form by selecting the Add button.

Foreign Priority Information:

This section allows for the applicant to claim benefit of foreign priority and to identify any prior foreign application for which priority is not claimed. Providing this information in the application data sheet constitutes the claim for priority as required by 35 U.S.C. 119(b) and 37 CFR 1.55(a).

		Re	move
Application Number	Country i	Parent Filing Date (YYYY-MM-DD)	Priority Claimed
			Yes ○ No
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Assignee Information:

Providing this information in the application data sheet does not substitute for compliance with any requirement of part 3 of Title 37 of the CFR to have an assignment recorded in the Office.

Assignee 1

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Application Data Sheet 37 CFR 1.76		Attorney Docket Number	MIO 0092 NA
Application ba	THE OTHER STOCK 1.70	Application Number	10/765,314
Title of Invention	Atomic Layer Deposition With	h Point Of Use Generated React	ive Gas Species
If the Assignee is a	n Organization check here.	Z	
Organization Name	Micron Technology, Inc.		
Mailing Address I	nformation:		
Address 1	8000 S. Federal Wa	у	
Address 2			
City	Boise	State/Provin	ice ID
Country US		Postal Code	83716-9632
Phone Number		Fax Number	
Email Address			
Additional Assigne button.	e Data may be generated v	vithin this form by selecting t	he Add

Signature:

A signature of the applicant or representative is required in accordance with 37 CFR 1.33 and 10.18. Please see 37 CFR 1.4(d) for the form of the signature.								
Signature	/William A. Jividen/		Date (YYYY-MM-DD)	2008-09-09				
First Name	William	Last Name	Jividen	Registration Number	42695			

This collection of Information is required by 37 CFR 1.76. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Condidentality is governed by 35 U. Sc. 122 and 37 FR 1.14. This collection is estimated to take 23 minutes to complete, including gathering, preparing, and submitting the completed application data sheet form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR